



Application No.: 09/813,548

Applicant(s)

Filed : March 21, 2001

Entitled : VAPOR DEPOSITION TREATED

ELECTRET FILTER MEDIA

: Richard E. Gahan et al.

Docket No. : 72545-28 Group Art Unit: 3761

Examiner: M. Patel

Certificate of Mailing (37 C.F.R. 1.8(a))

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November 17, 2003

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

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RESPONSE

TECHNOLOGY CENTER R3700

Dear Sir:

Applicants submit the following remarks in response to the final Office Action dated September 16, 2003.